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APPLICANTS

Shuichi Yamashita, Kariya-city, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\* NONE *W*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *YIC LV*

JAPAN 2003-79976 03/24/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
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Verified and Acknowledged

Examiner's Signature *[Signature]* Initials *W*

ADDRESS

23400  
 POSZ LAW GROUP, PLC  
 12040 SOUTH LAKES DRIVE  
 SUITE 101  
 RESTON, VA  
 20191

TITLE

Method for etching semiconductor substrate

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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